



Standards Watch

Volume 15, Issue 4



From the Director's Desk

James Amano, Senior Director

SEMI Standards – Official Virtual Meetings Underway

All Program Members will be able to participate and vote in any TC Chapter meeting remotely. [Read More](#)

New SEMI Standard for Chemical Mechanical Planarization Pad Hardness

New standards being developed to address critical CMP slurry and post-CMP measurements. [Read More](#)

Taiwan Flexible Hybrid Electronics Technical Committee Highlights

FHE System for Wearable Task Force to enable large scale adoption of FHE products designed for smart textile applications. [Read More](#)

200 mm Silicon Carbide Wafer Specification and Marking Update

Standards for 200 mm silicon carbide wafers and markings are progressing. [Read More](#)

Electron Microscopy Workflow Task Force Probes Industry Preferences for Automated TEM Workflow Solutions

Voice of key customers drives TEM Lamella Carrier standardization activity. [Read More](#)

Ballot for Automated Test Equipment Tester Event Messaging Out for Voting

SEMI ballot on TEMS is currently out for voting in Cycle 9. [Read More](#)

SEMI S2 Revision Related to Pressure Systems

To address compliance with high pressure safety requirements. [Read More](#)

Revisions to Regulations and Procedure Manual

Revisions of Regulations and Procedural Manual to address inactive TC Chapters. [Read More](#)

Japan Panel Level Packaging Panel FOUP Activity Highlights

Eight Panel Level Packaging Panel FOUP related documents have been developed and are approaching the finish line. [Read More](#)

Display Brightness Calculation to Match the Human Perception

Effort to update SEMI D75 (Color Reproduction and Perceptual Contrast of Display). [Read More](#)

China Compound Semiconductor Materials Technical Committee Chapter Highlights

New China SiC Epitaxial Wafer TF and Silicon Carbide Substrate TF approved. [Read More](#)

SEMI EHS Advocacy Webinar Key Takeaways

The semiconductor industry must do far more to educate the electronics supply chain on the subtle differences among various fluoropolymers. [Read More](#)

SEMI Webinar on Parts Cleaning for Critical Chamber Components

This 2-hour webinar will feature perspectives on OEM parts clean strategies, challenges, and design considerations. [Read More](#)

SEMI Coronavirus Resources

Please visit for updates to scheduled events, Best Practices and to find additional resources on industry's response to COVID-19. [Read More](#)
